Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
7	457	"445"/\$.ccls. and ((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((enclosure furnace chamber stage station) with (pressure atmosphere))	US-PGPUB; USPAT	OR	NO	2005/10/15 19:13
ៗ	239	"445"/24-25.ccls. and ((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((enclosure furnace chamber stage station) with (pressure atmosphere))	US-PGPUB; USPAT	OR.	N _O	2005/10/15 16:45
L4	100	"445"/24-25.ccls. and ((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((enclosure furnace chamber stage station) with (pressure atmosphere)) and ((plural plurality multiple different) with (enclosure furnace chamber stage station))	US-PGPUB; USPAT	SO.	NO	2005/10/15 16:46
51	125	"445"/24-25.ccls. and ((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((enclosure furnace chamber stage station) with (pressure atmosphere)) and ((plural plurality several multiple different individual separate) with (enclosure furnace chamber stage station))	US-PGPUB; USPAT	S.	NO	2005/10/15 16:47
97	224	"445"/\$.ccls. and ((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station) and ((enclosure furnace chamber stage station) with (pressure atmosphere)) and ((plural plurality several multiple different individual separate) with (enclosure furnace chamber stage station))	US-PGPUB; USPAT	S,	NO	2005/10/15 16:54
7	200	"445"/\$.ccls. and ((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((enclosure furnace chamber stage station) with (pressure atmosphere)) and ((plural plurality several multiple different individual separate) with (enclosure furnace chamber stage station)) and (firing fired bak\$3 calcinat\$3 heat\$3) and (seal\$3 attach\$3 bond\$3 bind\$3)	US-PGPUB; USPAT	OR	NO	2005/10/15 17:43
87		"6905384".pn.	US-PGPUB; USPAT	OR	NO	2005/10/15 17:27
6]	17	("20020039870" "4607593" "5066883" "5433639" "5564958" "5605483" "5653838" "5697825" "5749763" "5827102" "5876260" "6004181" "6049168" "6254449" "6479944" "6702636" "6821174").PN. OR ("6905384").URPN.	US-PGPUB; USPAT; USOCR	S.	NO	2005/10/15 17:27
L10		"445"/\$.ccls. and ((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((enclosure furnace chamber stage station) with (pressure vacuum atmosphere) with (degree reduc\$4 increas\$3 lower\$3)) and (firing fired bak\$3 calcinat\$3 heat\$3) and (seal\$3 attach\$3 bond\$3 bind\$3)	US-PGPUB; USPAT	OR.	N O	2005/10/15 17:50

at\$3) with (enclosure furnace US-PGPUB; OR ON 2005/10/15 17:51 chamber stage station) with duc\$4 increas\$3 lower\$3)) and essure vacuum atmosphere)) essure vacuum atmosphere))	with (enclosure furnace chamber stage lamber stage station) with (pressure reduc\$4 increas\$3 lower\$3)) and ((firing e (pressure vacuum atmosphere)) and mosphere)) and mosphere))	with (enclosure furnace chamber stage lamber stage station) with (pressure reduc\$4 increas\$3 lower\$3))	with (enclosure furnace chamber stage lamber stage station) with (pressure reduc\$4 increas\$3 lower\$3)) and (display	with (enclosure furnace chamber stage lamber stage station) with (pressure between stage station) with (pressure between stage station) with (image	EPO; JPO; OR ON 2005/10/15 18:01 DERWENT	EPO; JPO; OR ON 2005/10/15 18:01 DERWENT	DERWENT OR ON 2005/10/15 18:01	with (enclosure furnace chamber stage US-PGPUB; OR ON 2005/10/15 18:11 cinat\$3 heat\$3) same (pressure vacuum bond\$3 bind\$3) same (pressure vacuum
"445"/\$.ccls. and ((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((enclosure furnace chamber stage station) with (pressure vacuum atmosphere) with (degree reduc\$4 increas\$3 lower\$3)) and ((firing fired bak\$3 calcinat\$3 heat\$3) same (pressure vacuum atmosphere)) and ((seal\$3 attach\$3 bond\$3 bind\$3) same (pressure vacuum atmosphere)) and (clean\$3 same (pressure vacuum atmosphere))	((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((enclosure furnace chamber stage station) with (pressure vacuum atmosphere) with (degree reduc\$4 increas\$3 lower\$3)) and ((firing fired bak\$3 calcinat\$3 heat\$3) same (pressure vacuum atmosphere)) and ((seal\$3 attach\$3 bond\$3 bind\$3) same (pressure vacuum atmosphere)) and (clean\$3 same (pressure vacuum atmosphere))	((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((enclosure furnace chamber stage station) with (pressure vacuum atmosphere) with (degree reduc\$4 increas\$3 lower\$3))	((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((enclosure furnace chamber stage station) with (pressure vacuum atmosphere) with (degree reduc\$4 increas\$3 lower\$3)) and (displadevice panel)	((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((enclosure furnace chamber stage station) with (pressure vacuum atmosphere) with (degree reduc\$4 increas\$3 lower\$3)) and ((imagilat) near3 (display device panel))	"2000182524"	"2003059403"	2003-305707.NRAN.	((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((firing fired bak\$3 calcinat\$3 heat\$3) same (pressure vacuum atmosphere)) and ((seal\$3 attach\$3 bond\$3 bind\$3) same (pressure vacuum
92	91	8742 (2305 (70 8 8 8 9 9 9 9 9 9 9 9 9 9 9 9 9 9 9 9	2	4	1 2	156 (s
11	112	H3	114	115	116	L17	L18	119

2005/10/15 18:11	2005/10/15 18:44	2005/10/15 18:45	2005/10/15 18:46	2005/10/15 19:06	2005/10/15 19:09	2005/10/15 19:07	2005/10/15 19:13	2005/10/15 19:14	2005/10/15 19:24	2005/10/15 19:27
NO .	NO	N _O	NO	NO	NO	NO O	NO	NO	N O	NO
80	S.	OR	OR	S S	OR	OR	OR	OR	8	OR
US-PGPUB; USPAT	US-PGPUB; USPAT	US-PGPUB; USPAT	US-PGPUB; USPAT; USOCR	US-PGPUB; USPAT; USOCR	EPO; JPO; DERWENT	DERWENT	EPO; JPO; DERWENT	EPO; JPO; DERWENT	EPO; JPO; DERWENT	EPO; JPO; DERWENT
((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((firing fired bak\$3 calcinat\$3 heat\$3) same (pressure vacuum atmosphere)) and ((seal\$3 attach\$3 bond\$3 bind\$3) same (pressure vacuum atmosphere)) and ((clean\$3 getter\$3) same (pressure vacuum atmosphere)) and ((clean\$3 getter\$3) same (pressure vacuum atmosphere)) and "445"/\$.ccls.	((process\$3 manufact\$3 fabricat\$3) with (enclosure furnace chamber stage station)) and ((firing fired bak\$3 calcinat\$3 heat\$3) with (pressure vacuum atmosphere)) and ((seal\$3 attach\$3 bond\$3 bind\$3) with (pressure vacuum atmosphere)) and ((clean\$3 getter\$3) with (pressure vacuum atmosphere)) and ((clean\$2 getter\$3) with (pressure vacuum atmosphere)) and "445"/\$.ccls.	"6634916".pn.	("4904895" "5066883" "5591061" "5605483" "5749763" "5820435" "6049168" "6139390" "6254449" "6309272" "6419539").PN. OR ("6634916").URPN.	("4031552" "5529524" "5689151" "5697825" "5827102" "5936342" "5977706" "6008576" "6634916").PN. OR ("6926575").URPN.	"6926575"	2001-015679.NRAN.	"717429" "04289640" "05151916" "08022785" "08022785" "09082245" "09171768"	((process\$3 manufact\$3 operation\$3 fabricat\$3) with (vacuum pressure atmosphere) (enclosure furnace chamber stage station)) and ((flat image) near3 (display device panel apparatus))	((process\$3 manufact\$3 operation\$3 fabricat\$3) with (vacuum pressure atmosphere) with (similar "same" equal reduc\$4 lower\$3) with (enclosure furnace chamber stage station)) and ((flat image) near3 (display device panel apparatus))	((process\$3 manufact\$3 operation\$3 fabricat\$3) with (vacuum pressure atmosphere) with (constant uniform identical even equivalent) with (enclosure furnace chamber stage station)) and ((flat image) near3 (display device panel apparatus))
257	180	-	12	o,	н	H	15	23630	S	10
720	17.	777	173	124	175	977	777	87	173	L30

131	86	((process\$3 manufact\$3 operation\$3 fabricat\$3) with (vacuum pressure atmosphere) with (constant uniform identical even equivalent similar "same" equal increas\$3 decreas\$3 lower\$3 higher) with (enclosure furnace chamber at the contract of	US-PGPUB; OR	OR	NO	2005/10/15 19:29
132	12	stage station)) and ((nat iniage) nears (display device panel apparatus)) and ("445"/\$.ccls.) ("3611077").PN. OR ("6017259").URPN.	US-PGPUB; OR USPAT; USOCR	OR	NO	2005/10/15 19:32